

Notice of References Cited	Application/Control No. 10/604,565	Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Thao P. Le	Art Unit 2818	Page 1 of 1

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*	B	US-2004/0079979	04-2004	Lee et al.	257/301
*	C	US-6,740,555	05-2004	Tews et al.	438/242
*	D	US-5,395,786	03-1995	Hsu et al.	438/248
*	E	US-6,699,794	03-2004	Flietner et al.	438/700
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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